

Oxidative Coupling and Reforming of Methane with Carbon Dioxide Using a Pulsed Microwave Plasma under Atmospheric Pressure

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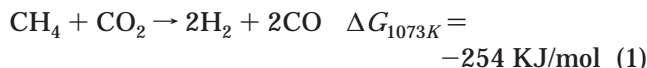
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A conventional high voltage wire-like plasma enhanced and spread by a pulsed microwave was used to study the oxidative coupling and reforming of CH₄ with CO₂ to CO, C₂H₂, C₂H₄, and H₂. Under the conditions of atmospheric pressure, a flow rate of 200 mL/min (CH₄/CO₂ = 1.5:1), peak microwave power of 120 W, and a pulse duty factor of 100/100 ms, conversions of CH₄ and CO₂ were 70.8% and 68.8%, respectively; selectivities to CO, C₂H₂, and C₂H₄ were, respectively, 75%, 17.8%, and 4.1%, and there was no carbon deposit. The ratio of H₂/CO increased with increasing CH₄ concentration in the feed gas, and a H₂/CO ratio of 2 could be obtained at a ratio 2:1 of CH₄ to CO₂, which is acceptable for Fischer-Tropsch and other synthesis processes. The energy efficiency of the pulsed microwave plasma was obviously improved. We suggested that this enhanced pulsed plasma is useful for oxidative coupling and reforming of CH₄ with CO₂ in C1 Chemistry.

1. Introduction

Methane and carbon dioxide are two major greenhouse gases, and carbon dioxide is present in many natural gas resources. Oxidative coupling and selective oxidation of methane to produce ethylene and higher hydrocarbon have received worldwide attention as a potentially interesting process for upgrading natural gas since 1982.¹ Oxidative coupling of methane to ethane² and ethylene³ requires a higher reaction temperature and higher pressure due to the similar high dissociation energy of activation of most C–H bonds. The most important reactions involving CO₂ are as follow:^{4,5} (1) the incorporation of CO₂ into the C–C, C–H, and C–N bonds with formation of carboxy and carbonyl compounds; (2) the oxidation of other hydrocarbons using CO₂ as an oxidant. However, there are some difficulties in conventional catalytic conversion of CO₂. The principal difficulty is from the intensive energy consumption and the expensive hydrogen source.⁶ Due to its high H–C ratio, methane is a very good co-reactant for CO₂ utilization. Most of these research interests focus on synthesis gas (CO + H₂) formation from CH₄ and CO₂ via reaction 1:^{7–16}



Such a reaction was first described by Fischer and

Tropsch using various catalysts such as Ni supported on silica at 860 °C.¹⁷ The high reaction temperature implied that this process is very costly.¹⁸ On the other hand, the undesirable carbon deposits are not avoidable with the present catalyst design in CO₂ reforming of CH₄.

As an effective approach, plasma technology has been applied to the conversion of CH₄ and CO₂. Larkin et al. studied the oxidative coupling of methane with carbon dioxide using an arc dielectric-barrier plasma reactor. The selectivities of oxygenates (methanol, formaldehyde, formic acid, methyl formate) amount to 50–65%.¹⁹ Zhou et al. studied methane reforming with carbon dioxide using a high-frequency AC nonthermal plasma. They found that most of the methane can be converted to carbon monoxide and hydrogen.²⁰ Huang et al. found that methane reforming with carbon dioxide using an AC arc plasma has a higher energy efficiency than using an AC glow plasma.²¹ Yao and co-workers reported the

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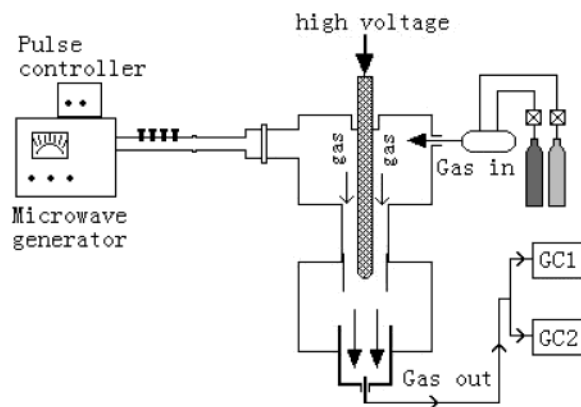


Figure 1. Schematic diagram of the experimental setup.

oxidative coupling and reforming of CH₄ with CO₂, using a high-frequency pulsed plasma, and have achieved a high energy efficiency.^{22,23} For oxidative coupling of methane using the microwave plasma with or without catalysts, some results at lower work pressure (23~50 Torr) have been reported.²⁴ But the oxidative coupling and reforming of CH₄ with CO₂ using pulsed microwave plasma at atmospheric pressure is relatively unexplored, which is probably due to difficulty in obtaining a low-temperature microwave plasma at atmospheric pressure.

Through a compatibility study of conventional high-voltage wire-like plasma and microwave cavity, a conventional wire-like plasma enhanced and spread by pulsed MW was chosen.²⁵ On one hand, the microwave can spread a wire-like plasma to form an umbrella-like plasma, whose area (or volume) is much expanded and the activation of plasma is enhanced; on the other hand, it inhibits abrupt transition of microwave discharge from deficient density to excessive density, which helps sustain a low-temperature nonequilibrium plasma. A plasma chemical reaction apparatus was manufactured in which high voltage discharged wire-like plasma was enhanced by pulsed microwave, and a low-temperature (about 500 °C, see ref 26) nonequilibrium microwave plasma was achieved at atmospheric pressure. Using this device, the oxidative coupling and reforming of CH₄ with CO₂ at atmospheric pressure was investigated. The conversions, selectivities, and energy efficiencies were reported.

2. Experimental Section

The experiment setup is schematically shown in Figure 1. The flow rate of feed gas was measured by a D07 mass flow controller and a D08 display unit (Beijing Jianzhong Machinery Factory), which were calibrated by a soap film meter. The frequency of the MW generator is 2450 MHz, with a maximum output power of 600 W and a pulse duration between 10 and 999 ms which is continuously adjustable. The pulsed MW plasma reactor was composed mainly of a coupling cavity, a coaxial line, and a resonance cavity. The high voltage is applied to the internal conductor to form a wire-like plasma between

the internal conductor and inner walls of the outer conductor. When pulsed microwave is introduced into the cavity, the wire-like plasma is enhanced and spread to form an umbrella-like plasma, which is continuously distributed in space. A short quartz tube with i.d. of 20 millimeter, that is attached to the end of the coaxial conductors, can be used to force the feed gas to flow across the plasma zone.

A mixture of methane and carbon dioxide was introduced into the coupling cavity and flowed through the plasma zone. Carbon compounds in the products from the exit of the reactor were analyzed with an online gas chromatograph (GC950, Shanghai Institute of computing-technique; TCD) equipped with a 2 m Porapak Q. Concentrations of H₂ and argon (internal standard gas for calculation of the carbon balance) were measured with another online gas chromatograph (GC920, Shanghai Institute of computing-technique; TCD) equipped with a 2 m TDX-01. All experiments were carried out at atmospheric pressure.

The overall conversions were defined as

$$\text{CH}_4 \text{ conversion} = \frac{[(\text{moles of CH}_4 \text{ before reaction}) - (\text{moles of CH}_4 \text{ after reaction})]}{(\text{moles of CH}_4 \text{ before reaction})} \times 100\%$$

$$\text{CO}_2 \text{ conversion} = \frac{[(\text{moles of CO}_2 \text{ before reaction}) - (\text{moles of CO}_2 \text{ after reaction})]}{(\text{moles of CO}_2 \text{ before reaction})} \times 100\%$$

Selectivity to CO was defined as

$$\text{CO selectivity} = \frac{(\text{moles of CO produced})}{[(\text{moles of CH}_4 \text{ converted}) + (\text{moles of CO}_2 \text{ converted})]} \times 100\%$$

Selectivity to C₂H₂ or C₂H₄ was defined as

$$\text{C}_2\text{H}_2 \text{ or C}_2\text{H}_4 \text{ selectivity} = \frac{(2 \times \text{moles of C}_2\text{H}_2 \text{ or C}_2\text{H}_4 \text{ produced})}{[(\text{moles of CH}_4 \text{ converted}) + (\text{moles of CO}_2 \text{ converted})]} \times 100\%$$

The input power for wire-like discharge is 5 W, and the peak power of microwave is between 80 and 160 W in our experiments. The pulse duration is represented with milliseconds.

The conversion ability of atmospheric pulsed microwave plasma is given (in mole of (CH₄ + CO₂)_(converted)/J_(plasma power)) as

$$\text{conversion ability} = \frac{(\text{moles of CH}_4 \text{ and CO}_2 \text{ converted during one minute})}{60P}$$

which can represent the energy efficiency of the pulsed microwave plasma.

3. Results and Discussion

3.1. Influence of Pulse Frequency. We first investigated the influence of pulse frequency at a CH₄/CO₂ ratio of 3/2. The pulse duty factor was set at 1/1, with increasing of pulse duration from 50 to 500 ms, the pulse frequency decreased from 10 PPS to 1 PPS. Conversions of CH₄ and CO₂ decreased with increasing pulse duration from 50 to 350 ms, and there were the minimal values at the pulse duration of 350 ms, which was shown in Figure 2. CH₄ conversion was higher than CO₂ conversion, as there are some CO₂ formation reactions:



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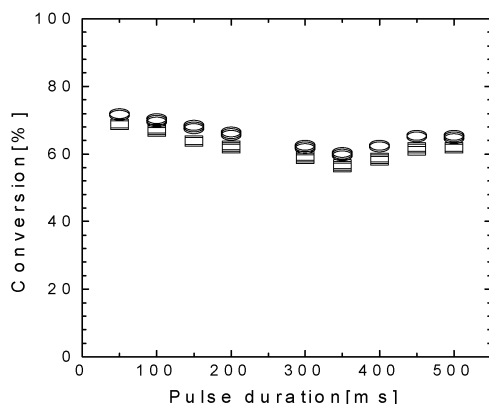


Figure 2. Influence of pulse duration on methane (○) and carbon dioxide (□) conversions. $\text{CH}_4/\text{CO}_2 = 1.5:1$, pulse duty factor = 1:1, peak power of MW = 120 W, feed flow rate = 200 mL/min.

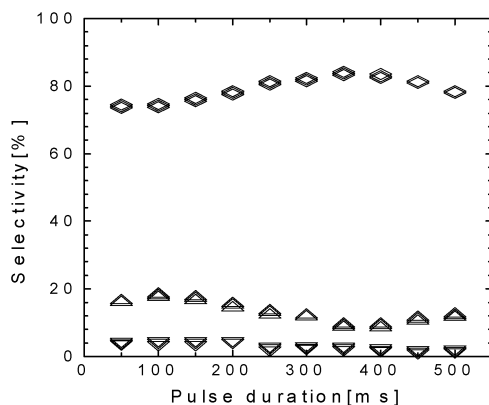


Figure 3. Selectivities of CO (◇), C_2H_2 (△), and C_2H_4 (▽) at various pulse durations. $\text{CH}_4/\text{CO}_2 = 1.5:1$, pulse duty factor = 1:1, peak power of MW = 120 W, feed flow rate = 200 mL/min.

The minimal values of conversions came from the dimension of reactor and the feed flow rate. The i.d. of the coaxial line and quartz tube is 20 mm; when the flow rate of feed gas passing across the plasma is 200 mL/min, the linear gas velocity is 10.6 mm/s. Viewed from the side, the thickness of the umbrella-like plasma zone in the experiments is about 5 mm, so the residence time of feed gas in the plasma zone is about 470 ms. Considering the factor that abrupt volume expansion of feed gas in the pulsed MW plasma would result in a backflow toward the plasma zone, the time in which the unit mass of feed gas passing through the plasma zone is longer than 470 ms. With a pulse duty factor of 1/1, when the pulse duration is longer (e.g., 300, 350, and 400 ms), a part of the feed gas would flow across the plasma zone without being activated during the intermission of plasma, which results in the decrease of conversions. When the pulse duration is short (e.g., 100 and 200 ms), a unit mass of feed gas flowing across the plasma could experience 2–3 pulses of time of MW plasma although single pulse duration is shorter, so the conversions could also reach a high value.

In the products, there is only a spot of steam (H_2O) produced (eq12) and no oxygen observed, so the H_2O was ignored in the analysis.

The selectivity to CO increased with the increase in the pulse duration, but selectivity to C_2H_2 and C_2H_4 decreased (Figure 3). This implied the rapid quenching

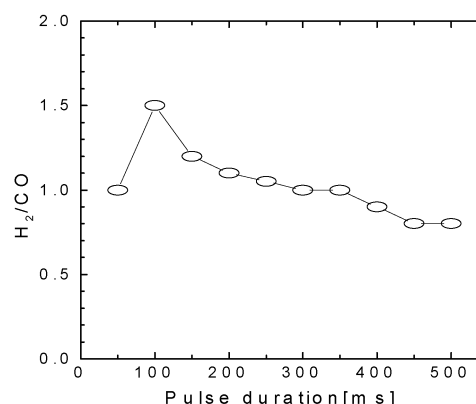


Figure 4. Ratios of H_2/CO at various pulse durations. Conditions are the same as those in Figure 3.

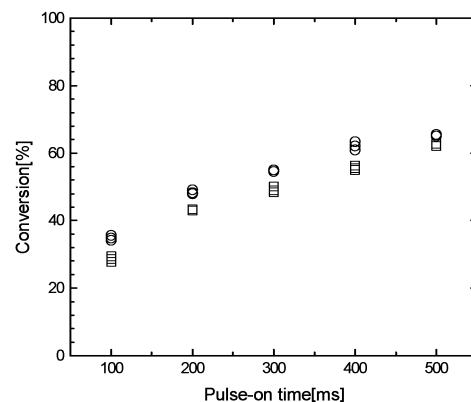


Figure 5. Influence of pulse-on time on methane (○) and carbon dioxide (□) conversions. $\text{CH}_4/\text{CO}_2 = 1.5:1$, pulse intermission = 500 ms, peak power of MW = 120 W, feed flow rate = 20 mL/min.

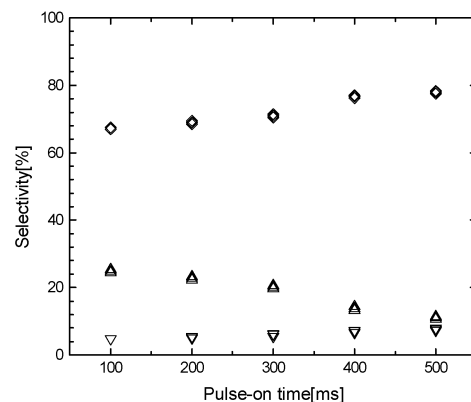
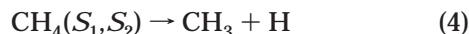
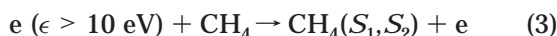


Figure 6. Selectivities of CO (◇), C_2H_2 (△), and C_2H_4 (▽) at various pulse-on times. Conditions are the same as those in Figure 5.

of effluent was important for the formation of C_2H_2 . But it is still unknown why there is no trace of C_2H_6 in the products. The ratio of H_2/CO in the product is shown in Figure 4. The H_2/CO ratio peaked at a pulse duration of 150 ms. The H_2/CO ratio was lower than 1.0 when pulse duration exceeded 400 ms.

3.2. Influence of Pulse-on Time. For investigating the enhancement effect of pulsed microwave, we studied the influence of changing the pulse-on time. In the experiments, the pulse intermission of microwave was set at 500 ms, the pulse-on time increased from 100 to 500 ms. Conversions of CH_4 and CO_2 at various pulse

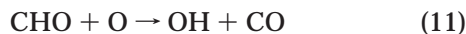
durations are shown in Figure 5. Conversions of CH₄ and CO₂ increased remarkably when the pulse-on time increased. The increases in conversion of CH₄ and CO₂ were obviously due to the increase in input power. The selectivity to each product is shown in Figure 6. The selectivity to CO increased and that of C₂H₂ decreased as the pulse-on time increased. The selectivity to C₂H₄ did not change significantly. It was found, that in a plasma process, the most important reactions for CH₄ consumption are the electron-impact dissociation to radicals CH_x ($x = 0,1,2,3$), as was already pointed out by Oumghar et al.²⁷ and Shigeru et al.²⁸



CO₂ can be dissociated to produce reactive species including O, oxygen anion in plasma reaction:^{4,29}



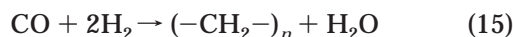
C₂H₂ and C₂H₄ are mainly formed via the recombination of radicals. Expect for the dissociation of carbon dioxide, reactive oxygen species could result in formation of CO via reactions:²⁹



The change of CO and C₂H₂ selectivities with pulse-on time (namely, the residence time of feed gas in the plasma zone) indicated that the rapid quenching of plasma favors the production of acetylene.

3.3. Influence of CH₄ Concentration in Feed Gas.

The main products are CO and H₂ in methane coupling and reforming with carbon dioxide using pulsed microwave plasma. The synthesis gas (CO + H₂) is mainly used to produce liquid fuels and other chemicals via the Fischer–Tropsch reaction, and to produce CH₃OH via the following reactions:



The dry reforming of CH₄ with CO₂ is usually carried

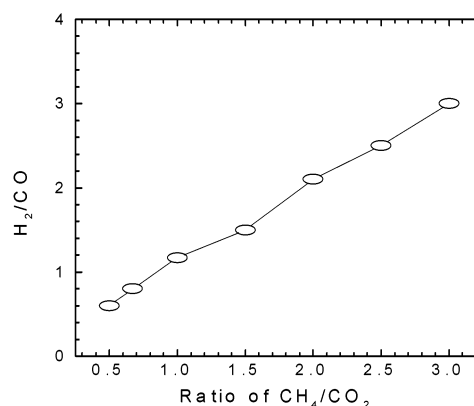


Figure 7. Ratios of H₂/CO at various ratios of CH₄/CO₂. Pulse duty factor = 100/100 ms, peak power of MW = 120 W, feed flow rate = 200 mL/min.

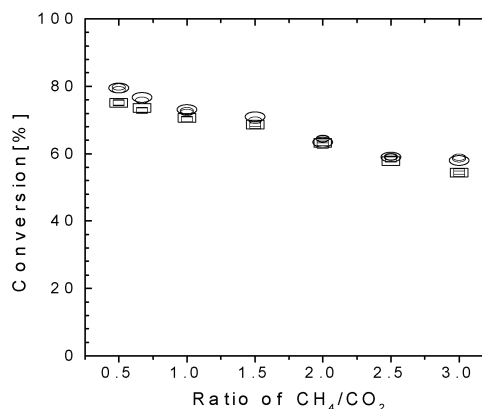
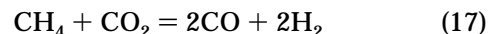


Figure 8. Influence of CH₄/CO₂ ratio on methane (○) and carbon dioxide (□) conversions. Pulse duty factor = 100/100 ms, peak power of MW = 120 W, feed flow rate = 200 mL/min.

out at a ratio 1:1 of CH₄ to CO₂, yielding a 1:1 mixture of H₂ and CO (eq 17):



Since the synthesis gas from dry reforming of CH₄ (eq 16) cannot be directly used for Fischer–Tropsch reaction and CH₃OH production, the reaction yielding a high H₂/CO is required. We then carried out CH₄ reforming with CO₂ at various ratios of CH₄ to CO₂ and at a fixed total flow rate of 200 mL/min, the pulse duty factor was set at 100 ms/100 ms, and the peak power of microwave was 120 W. The H₂/CO ratio increased remarkably with increasing CH₄ concentration in the feed gas (Figure 7). A H₂/CO ratio of 2 could be obtained at a ratio 2:1 of CH₄ to CO₂.

The conversions of CH₄ and CO₂ at various ratios of CH₄ to CO₂ are shown in Figure 8. Conversions of both CH₄ and CO₂ decreased with increasing CH₄ concentration. Although conversions of CH₄ and CO₂ were highest at 0.5 ratio of CH₄ to CO₂, the plasma would ablate the internal conductor after a long time, which could influence the stability of plasma. Conversions of both CH₄ and CO₂ could kept around 60~70% at a ratio of CH₄ to CO₂ from 1.5:1 to 2:1. This satisfied the next process of synthesis gas since a H₂/CO ratio of 1.5 to 2 could be given. The selectivity to each product is illustrated in Figure 9. Selectivity to CO decreased, but that of C₂H₂ and C₂H₄ increased with increasing the ratio of CH₄ to

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Table 1. Comparison of Conversion Ability to Other Plasmas

plasma	feed	flow (mL/min)	pressure (Torr)	P (W)	T (°C)	CH conversion (%)	selectivity (%)				conversion ability (μ mol/J)	ref
							C ₂ H ₂	C ₂ H ₄	CO	CH ₃ OH		
microwave microwave/ catalyst silent silent	CH ₄	100	23	80		26	24	23.5			0.22	24
	CH ₄	500	50	80		8	23.5	0			0.34	24
	CH ₄ + O ₂	27.5	760	8	110	2.5		7.1	21.3	20	0.059	32
	CH ₄ + O ₂ /C ₂ H ₆	430	760	118	28	CH ₄ , 31.8 C ₂ H ₆ , 20 O ₂ , 33			18 ^a	36 ^b	0.37	30
pulsed AC	CH ₄ + O ₂ /Ar	190	760	21	room	17		16 ^c	54	24	0.36	31
dielectric-barrier	CH ₄ + CO ₂	500	760	500	80	CH ₄ , 40 CO ₂ , 20			88.5		0.18	20
AC arc ^d	CH ₄ + CO ₂	75	760	30		CH ₄ , 88.9 CO ₂ , 53.2	11.2	2.26	81.5		0.15	21
pulsed 3050PPS	CH ₄ + CO ₂	100	760	29.5	room	CH ₄ , 26.7 CO ₂ , 17.2		61.6	19.8		0.58	22
pulsed 2920PPS	CH ₄ + CO ₂	100	760	30.6	500	CH ₄ , 31.8 CO ₂ , 23.9		63.7	22.1		0.68	22
pulsed microwave plasma	CH ₄ + CO ₂	200	760	65	500	CH ₄ , 70.8 CO ₂ , 68.8	17.8	4.1	75		1.56	this study

^a (CO + CO₂). ^b (CH₃OH + HCOH + HCOOH + C₂H₅OH + HCOOCH₃). ^c (C₂H₄ + C₂H₆). ^d CH₄ and CO₂ (5/5) both excited; maximum energy efficiency.

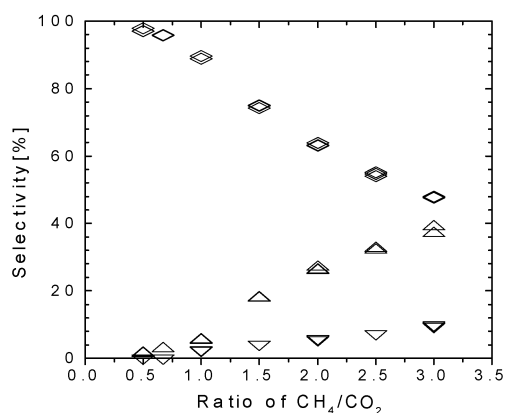


Figure 9. Selectivities of CO (◇), C₂H₂ (Δ), and C₂H₄ (▽) at various ratios of CH₄/CO₂. Conditions are the same as those in Figure 8.

CO₂. It must be mentioned that there appeared black polymer films on the inner wall of quartz tube when the ratio of CH₄ to CO₂ was more than 2.5:1. This indicated that the reactive oxygen from CO₂ dissociation plays an important role in inhibiting exorbitant dehydrogenation of methane and polymerization of methyl radicals. Since C₂H₂ and C₂H₄ are both important raw materials and H₂ is a clean energy source, this indicated that we could get these important chemicals by adjusting the ratio of CH₄ to CO₂.

3.4. Energy Efficiency of Pulsed Microwave Plasma. Almost all of the plasma experiments indicated that the energy required by the process is the highest in comparison with the others, such as a thermal chemical process. The energy efficiency of a pulsed microwave plasma is represented by a conversion ability of CH₄ and CO₂, and the energy efficiency at various microwave peak powers are shown in Figure 10. Under a fixed flow rate of 200 mL/min (CH₄/CO₂ = 1.5/1) and pulse duty factor of 100 ms/100 ms, the energy efficiency peaked at 120 W of microwave peak power. This indicated that the energy efficiency can be improved by

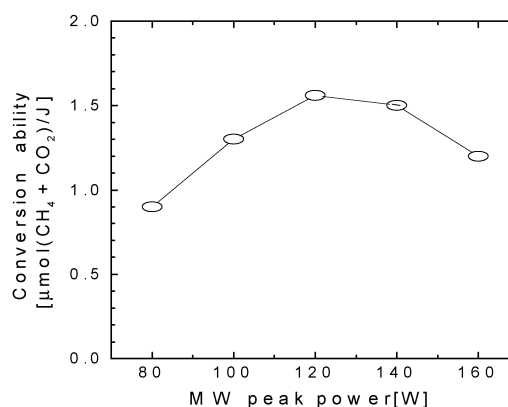


Figure 10. Conversion ability of CH₄ and CO₂ at various microwave peak powers. CH₄/CO₂ = 1.5:1, pulse duty factor = 100/100 ms, feed flow rate = 200 mL/min

increasing the input microwave power, but there is an upper limit at a fixed flow rate.

A comparison of our results with others using low-temperature plasma methods reported by Larkin,³⁰ Omumoto,³¹ Shepelev,³² Suib,²⁴ Zhou,²⁰ and Yao²² is given in Table 1. The energy efficiency using this pulsed microwave plasma is better than that using other plasma technologies, including silent, dielectric-barrier discharges, and high-frequency pulsed plasma, and is also better than other microwave plasma with or without catalysts.

The selectivity to CO could reach as high as 97% when the ratio of CH₄ to CO₂ is 1:2 using this pulsed microwave plasma under atmospheric pressure; the selectivities of acetylene and ethylene decreased with the increase of CO₂ concentration in the feedstock.

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These facts indicate that the selectivity to each product can be adjusted easily according to the demand of subsequent chemical synthesis. So this kind of pulsed microwave plasma can believably promote the application of plasma technologies for methane and carbon dioxide conversions.

4. Conclusions

This study demonstrates the following:

(1) The pulsed microwave under atmospheric pressure is an effective method for oxidative coupling and reforming of CH_4 and CO_2 .

(2) Under a condition of 1.5:1 volume ratio of CH_4 to CO_2 , total flow rate of 200 mL/min, microwave peak power of 120 W and pulse duty factor of 100 ms/100 ms, single pass conversions of CH_4 and CO_2 were around

70% and 68%, selectivities of CO, C_2H_2 , and C_2H_4 , H_2/CO ratio were, respectively, 75%, 17.8%, 4.1%, and 1.5.

(3) The selectivities of CO and C_2 (C_2H_2 and C_2H_4) could be adjusted by changing the ratio of CH_4 and CO_2 ; the H_2/CO ratio increased with an increase of CH_4/CO_2 ratio in feedstock.

(4) The energy efficiency is improved by increasing input power of microwave, but it peaked 1.56 at a fixed feed composition of $(120\text{CH}_4 + 80\text{CO}_2)$ mL/min and a pulse duty factor of 100 ms/100 ms.

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